

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|--------|---|---|------------------|---------|------------------|
| S36 | 34886 | (ohmic near contact) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/11/08 16:50 |
| S37 | 340660 | diffusing or diffused or diffuse | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/11/08 16:51 |
| S38 | 64549 | a-si or (amorphous near silicon) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/11/08 16:51 |
| S39 | 534 | (remove or removing or removed) near8 (impurity or impurities) near8 channel | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/11/08 16:54 |
| S40 | 7 | S36 same S39 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/11/08 16:57 |
| S41 | 43 | S36 and S39 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/11/08 16:57 |
| S42 | 25 | S41 and ((@ad<"20010219") or (@rlad<"20010219")) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/11/08 17:04 |
| S43 | 11744 | S37 near8 (impurity or impurities or phosphorous or P) near8 (a-si or amorphous or semiconductor) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/11/08 17:03 |

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|-----|------|--|---|----|-----|------------------|
| S44 | 3337 | ((438/149) or (438/151) or (438/156) or (438/482)).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/11/08 17:04 |
| S45 | 135 | S43 and S44 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/11/08 17:04 |
| S46 | 91 | S45 and ((@ad<"20010219") or (@rlad<"20010219")) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/11/08 17:10 |
| S47 | 16 | S46 and S36 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/11/08 17:11 |
| S48 | 4 | ("4892837" "5700714" "5981317" "6251715").PN. | US-PGPUB; USPAT; USOCR | OR | ON | 2005/11/08 17:12 |